



cjc

00862.022205

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:)
Yoshiyuki NAGAI et al.)
Application No.: 09/839,139)
Filed: April 23, 2001)
For: LASER OSCILLATION APPARATUS,)
EXPOSURE APPARATUS, SEMICONDUCTOR)
DEVICE MANUFACTURING METHOD,)
SEMICONDUCTOR MANUFACTURING)
FACTORY, AND EXPOSURE APPARATUS)
MAINTENANCE METHOD)
U.S. Patent No. 6,870,865 B2)
Issued: March 22, 2005)
Examiner: M. Landau
Group Art Unit: 2815
June 21, 2005

Certificate
JUL 08 2005
of Correction

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Attention: Certificate of Correction Branch

LETTER CALLING ATTENTION TO ERRORS IN PATENT

Sir:

Patentees note the following errors in the above-identified patent:

ON THE COVER PAGE:

In item "(56) **References Cited**," under "OTHER PUBLICATIONS" in line 2, "pat nt"
should read -- patent --.

COLUMN 8:

Line 30, "osillation" should read -- oscillation --.

Line 31, "osillation" should read -- oscillation --.

COLUMN 11:

Line 37, "hose" should read -- host --.

These errors are relatively insignificant. Therefore, Patentees believe that filing a Request for Certificate of Correction is not warranted. Rather, Patentees request that this paper be placed of record in the official file of the subject patent.

Patentees believe no fee is due for filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed required.

Patentees' undersigned attorney may be reached in our Washington, D.C. Office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Steven E. Warner", written over a horizontal line.

Attorney for Patentees
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
SEW/eab

DC_MAIN 206961v1